

Title: System, Method and Apparatus for Applying Liquid To A CMP Polishing Pad Application No: 10/676,388 File No: LAM2P441 Inventors: Pham et al. Page 1 of 9

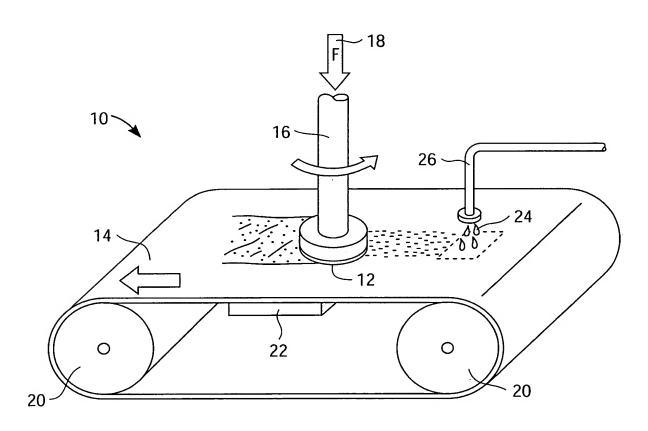


FIG. 1A (PRIOR ART)

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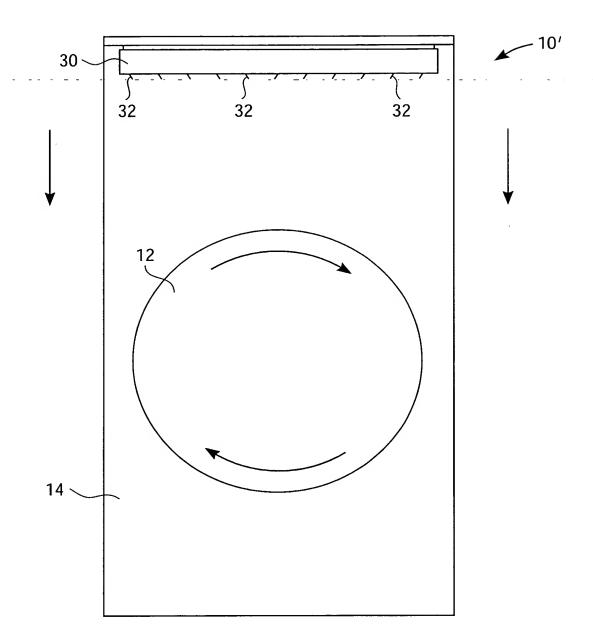


FIG. 1B

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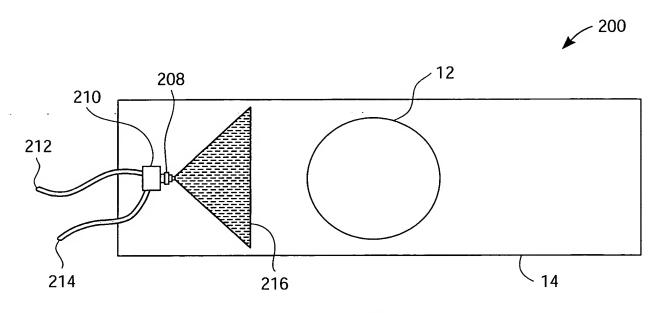


FIG. 2A

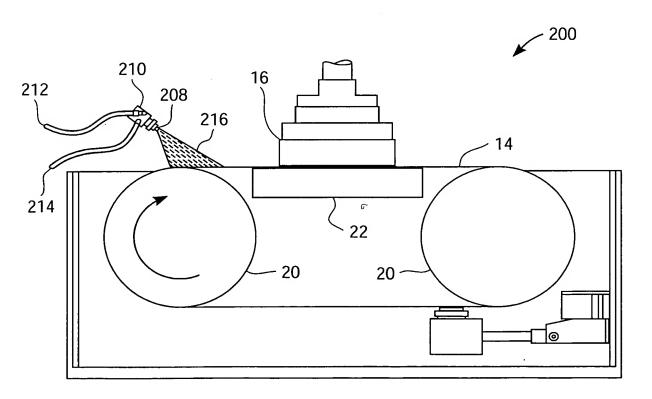


FIG. 2B

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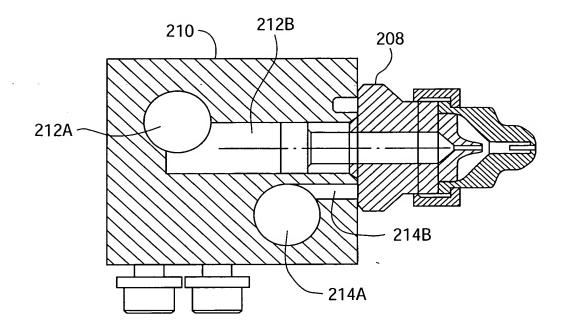


FIG. 3

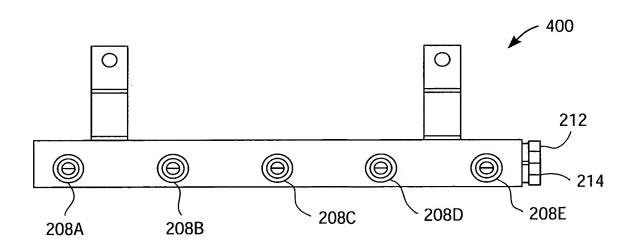
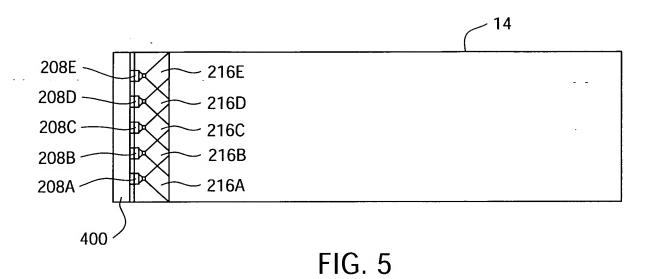
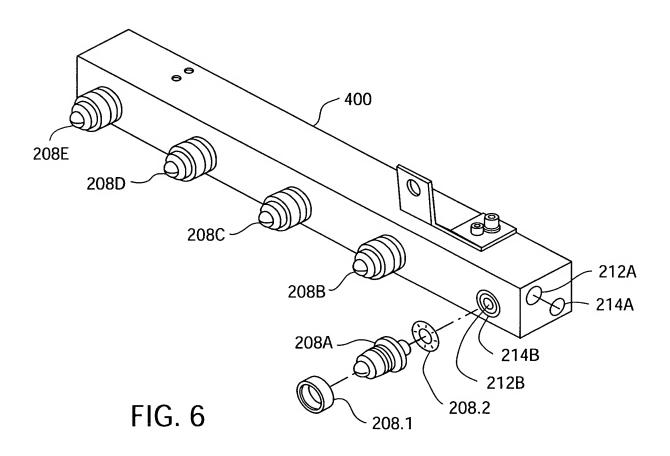


FIG. 4

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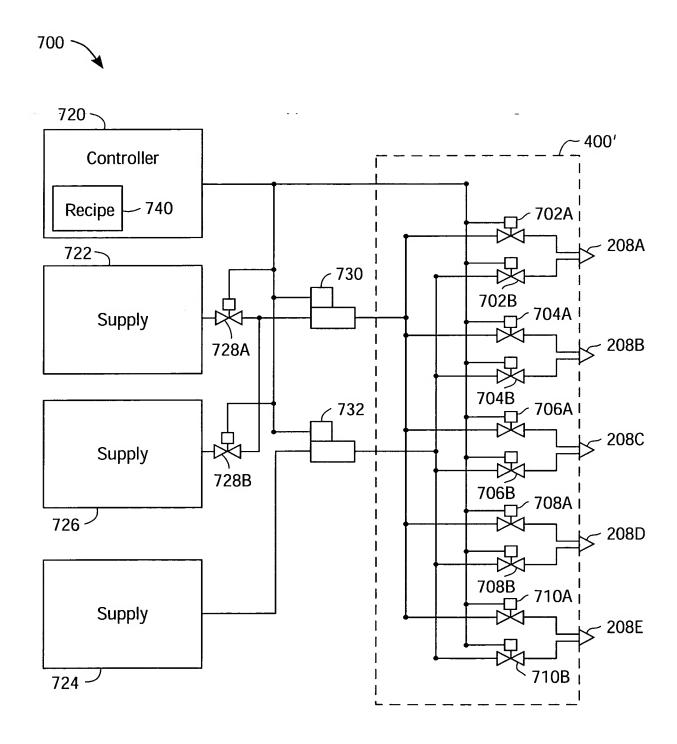


FIG. 7

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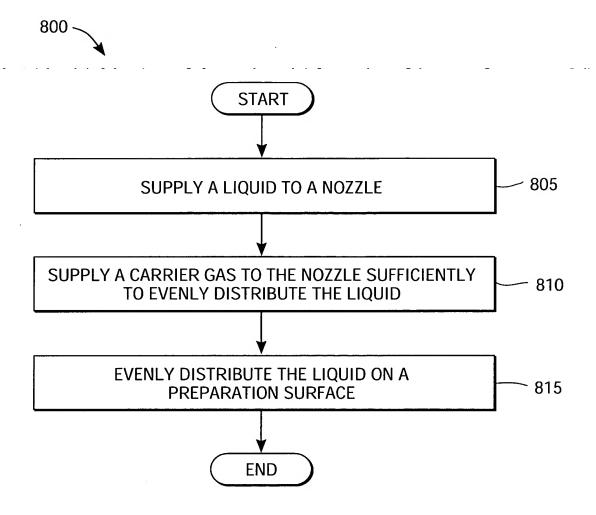


FIG. 8

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FIG. 9

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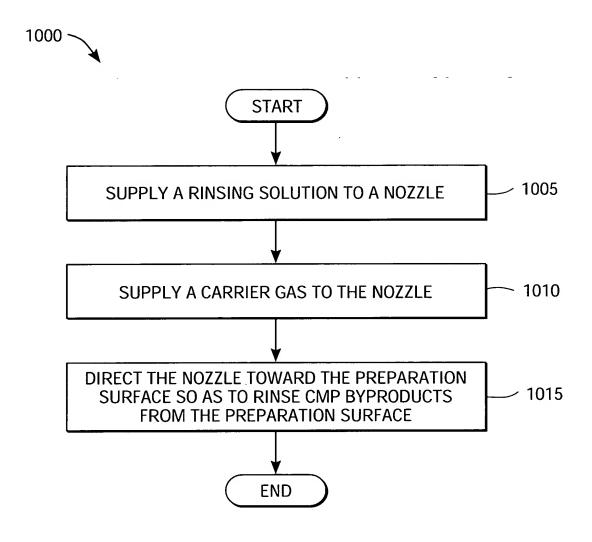


FIG. 10